



NIT-288

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

N. KOFUJI et al

Serial No. 09/920,834

Group Art Unit: 1765

Filed: August 3, 2001

Examiner: K. C. Chen

For: METHOD AND APPARATUS FOR FABRICATING
SEMICONDUCTOR DEVICES

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AMENDMENT

Commissioner for Patents
Alexandria, VA 22313

Sir:

In response to the Office Action dated February 28, 2003,
please amend the above-identified application as follows.

07/02/2003 CCHAU1 00000013 09920834

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